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Inventor ..... John T. Moore  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... T. Pham  
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Title: Methods of Forming Oxide Regions Over Semiconductor Substrates

Assistant Commissioner for Patents  
Washington, D.C. 20231

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

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1. Supplemental Information Disclosure Statement w/PTO-1449 and copy of cited reference

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